

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT			ATTY. DOCKET NO. 1857.0350000	APPLICATION NO. 09/841,187			
			APPLICANT NELSON <i>et al.</i>				
			FILING DATE April 25, 2001	GROUP 2851			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
	AA1						
	AB1						
	AC1						
	AD1						
	AE1						
	AF1						
	AG1						
	AH1						
	AI1						
	AJ1						
	AK1						
FOREIGN PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION
	AL1						Yes No
	AM1						Yes No
	AN1						Yes No
	AO1						Yes No
	AP1						Yes No
OTHER (Including Author, Title, Date, Pertinent Pages, etc.)							
<i>DR</i>	AR	1	Advanced Focus System Development Task Proposal Submitted in response to Advanced Lithography SOL BAA 99-14, March 2, 1999, pp. 1-34, Silicon Valley Group, Inc., Lithography Division				
	AS	1					
	AT	1					
EXAMINER: <i>D. Benjamin</i>					DATE CONSIDERED <i>6/5/03</i>		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							